

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
)	
Kazuya FUKUHARA)	Group Art Unit: 2624
)	
Application No.: 10/776,591)	Examiner: Mia M. THOMAS
)	
Filed: February 12, 2004)	
)	Confirmation No.: 3478
For: INSPECTION METHOD,)	
PROCESSOR AND METHOD FOR)	
MANUFACTURING A)	
SEMICONDUCTOR DEVICE)	

MAIL STOP RCE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT

This amendment is being filed along with a Request for Continued Examination (RCE) and satisfies the requirement for a submission as set forth in 37 C.F.R. § 1.114. In response to the Office Action mailed August 19, 2008, the period for response to which extends through November 19, 2008, please amend the above-identified application follows:

Amendments to the Claims are reflected in the listing of claims in this paper beginning on page 2.

Remarks follow the amendment sections of this paper beginning on page 8.